



Metallurgical Microscope

ME-LUX2 Series UPRIGHT Type

VARIATIONS

- Model ME-LUX2-2
 (Binocular type, Koehler type incident illumination)
- Model ME-LUX2-3C (Trinocular type with C-mount adapter tube to accept video and digital camera, Koehler type incident illumination)
- Model ME-LUX2-3P
 (Trinocular type with vertical photo tube to accept photography attachment, Koehler type incident illumination)
- Model ME-LUX2-2L/3CL/3PL
 (As same as above but with Koehler type incident and transmitted dual illumination)

FEATURES:

- •Rigid and reliable construction,
- Wide range of materials applications,
- High resolution optics,
- Attractive pricing for a high quality microscope,
- Simple operation for routine studies,

APPLICATIONS:

- General work in the metallurgical laboratory,
- Quality control and inspection,
- Electronic and semiconductor circuits,
- Examination of polymer, paints and coatings,
- Chemical industry materials examination,



■ Model ME-LUX2-3PL

By the ideal combination of the top quality optical components and the precisely finished mechanical systems, ME-LUX2 series
Metallugical Microscope offers a solid investment to generate bulk and immediate value, which is secured by KYOWA's long technical experience accumulated in over 60 years.

ength ly construction ent ME-LUX2 ME-LUX2-L	Coaxial coarse and f and fine adjustment of 100 divisions,(0.0 Rectangular stage w	type with ball bearing function fine adjustment, with focus range by 30mm for both coarse for per a rotation of fine adjustment by 1mm with graduation finm) first 185mm × 140mm surface with graduated low positioned		
ent ME-LUX2	Right angled sturdy Quintuple revolving Coaxial coarse and f and fine adjustment of 100 divisions,(0.0) Rectangular stage w coaxial control knob	type with ball bearing function fine adjustment, with focus range by 30mm for both coarse for per a rotation of fine adjustment by 1mm with graduation finm) first 185mm × 140mm surface with graduated low positioned		
ent ME-LUX2	Quintuple revolving Coaxial coarse and f and fine adjustment of 100 divisions,(0.0) Rectangular stage w coaxial control knob	type with ball bearing function fine adjustment, with focus range by 30mm for both coarse for per a rotation of fine adjustment by 1mm with graduation finm) fith 185mm × 140mm surface with graduated low positioned		
ME-LUX2	Coaxial coarse and f and fine adjustment of 100 divisions,(0.0.2 Rectangular stage w coaxial control knob	tine adjustment, with focus range by 30mm for both coarse s, per a rotation of fine adjustment by 1mm with graduation 1mm) with 185mm × 140mm surface with graduated low positioned		
	coaxial control knob			
ME-LUX2-L		Rectangular stage with 185mm × 140mm surface with graduated low positioned coaxial control knob to slide stage plate in X and Y axis, with movable range by 52mm × 77mm,		
	- Ditto – but with 160mm × 140mm surface, with movable range by 50mm × 75mm			
Condenser Abbe type N.A. 1.25 condenser with iris diaphragm and rack &pinion		5 condenser with iris diaphragm and filter holder, focused		
or ME-LUX2-2	Inclined 45° binocular head, with interpupilary distance adjustment from 54mm to 74mm and diopter adjustment ring on both left and right eyepiece sleeve,			
For ME-LUX2-3P		- Ditto - but with built-in beam splitter to divide optical path for 100% to binocular and 0% to photo tube, or 80% to binocular and 20% to photo tube, and with vertical photo tube to accept photomicrography attachment,		
or ME-LUX2-3C		rith vertical C-mount adapter tube to accept C-mount video camera		
or E-LUX2-2/3C/3P	Built-in incident illuminator with 6V/20W halogen lamp with transformer and variable intensity control built-in base, Field and aperture diaphragms for Koehler type illumination with filter slot,			
or ME-LUX2-L	· Ditto · but built-in incident and transmitted dual illumination,			
Optical Components		Widefield and high eye-point eyepiece, WHE10×paired,		
		Parfocal Din type Planachromat metallurgical objectives with special multi-layer coating for high resolution to increase clear contrast, M-Plan 5×, 10×, 20×,40×(Spring),		
		From 50× to 400×,		
Standard Accessories		Green and yellow filters (each 1 pc.) Daylight blue filter, $32.8 \text{mm} \phi$ Dust cover, Spare bulb, $6\text{V}/20\text{W}$ halogen for incident and transmitted,		
	or ME-LUX2-3P or ME-LUX2-3C or ME-LUX2-3C or ME-LUX2-2/3C/3P or ME-LUX2-L	with movable range Abbe type N.A. 1.2 rack &pinion Inclined 45° binocular adjustment from 54 right eyepiece sleeved Ditto - but with binocular and 0% to with vertical photo of the core ME-LUX2-3C OF ME-LUX2-3C OF ME-LUX2-3C OF ME-LUX2-2/3C/3P OF ME-LUX2-2/3C/3P OF ME-LUX2-2/3C/3P OF ME-LUX2-2/3C/3P OF ME-LUX2-1 OF		

	Eyepiece, WH15 x, widefield and high eye-point type,	
Optional Accessories	Eyepiece, K20×, compensation type,	
	Objective, M-Plan60×, planahromat Din type, spring mount,	
	Objective, M-Plan 100×, planahromat Din type, spring mount,	
	Wooden carrying case with handle, lock and keys,	

Technical Data of optical components						
Eyepieces	Field No.	Eye Point	Focal Length			
WHE 10	18.0	20.0	25.0			
WH 15	14.0	14.0	16.7			
K20	8.0	11.0	12.5			

Objectives	N.A.	W.D	Remark
M-Plan 5×	0.10	16.5	
M-Plan 10×	0.25	7.5	
M-Plan 20×	0.40	8	
M-Plan 40×	0.65	0.6	Spring
M-Plan 60×	0.85	0.2	Spring
M-Plan 100×	0.80	0.5	Spring, Dry

•All specifications subject to change without prior notice.